

FORM PTO-1449

U.S. Department of Commerce  
Patent and Trademark OfficeAtty. Doct No.  
P21060Application No.  
09/995,696INFORMATION DISCLOSURE STATEMENT  
BY APPLICANT  
(Use several sheets if necessary)Applicant  
Takefumi WAKABAYASHIFiling Date  
November 29, 2001Group  
2157

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES NO
S.N.	2000 - 2 2 2 3 3 3	08/11/00	JAPAN			
S.N.	10 - 2 6 9 0 3 9	10/09/98	JAPAN			
S.N.	11 - 0 0 8 7 2 7	01/12/99	JAPAN			
S.N.	2002 - 1 1 1 9 4 6	04/12/02	JAPAN			
S.N.	2001 - 0 5 6 7 8 9	02/27/01	JAPAN			
S.N.	2000 - 3 1 1 0 9 5	11/07/00	JAPAN			
S.N.	2 - 1 7 2 3 4 8	07/03/90	JAPAN			
S.N.	6 - 2 7 6 3 1 3	09/30/94	JAPAN			
S.N.	11 - 2 3 4 4 5 4	08/27/99	JAPAN			

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

S.N.	1	English Language Abstract of JP 2000-222333.
S.N.	2	English Language Abstract of JP 10-269039.
S.N.	3	English Language Abstract of JP 11-008727.
S.N.	4	English Language Abstract of JP 2002-111946.
S.N.	5	English Language Abstract of JP 2001-056789.
S.N.	6	English Language Abstract of JP 2000-311095.
S.N.	7	English Language Abstract of JP 2-172348.
S.N.	8	English Language Abstract of JP 6-276313.
S.N.	9	English Language Abstract of JP 11-234454.

EXAMINER SARGON NANO

DATE CONSIDERED 2-21-06

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